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2-14-02
Docket: 740756-2417

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re New Patent Application of)
Shunpei YAMAZAKI et al.)
Japanese Priority Application No. 2001-010858) Attn: Applications
Japanese Priority Date: January 18, 2001) Branch
For: METHOD OF MANUFACTURING)
SEMICONDUCTOR DEVICE) Date: January 3, 2002



INFORMATION DISCLOSURE STATEMENT

Honorable Commissioner for Patents and Trademarks
Washington, D.C. 20231

Sir:


In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the references listed on the attached Form PTO-1449 be made of record in the above-identified application.

At least some of the references listed on PTO Form-1449 are discussed in the specification of the present application.

Copies of these references are submitted herewith in accordance with 37 C.F.R. 1.98(a).

U.S. Patent Nos. 5,643,826; 5,923,962 and 6,285,042 are listed in the family of Japanese Patent Application Laid-Open No. 07-183540.

Respectfully submitted,


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